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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/767,618	01/29/2004	Chen-Hsiung Cheng	9432-158DVB 5657 EXAMINER	
27572	7590 09/06/2006			
HARNESS, DICKEY & PIERCE, P.L.C.			ABOAGYE, MICHAEL	
P.O. BOX 828 BLOOMFIELD HILLS, MI 48303			ART UNIT	PAPER NUMBER
			. 1725	
			DATE MAILED: 09/06/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/767,618	CHENG ET AL.				
Office Action Summary	Examiner	Art Unit				
	Michael Aboagye	1725				
The MAILING DATE of this communication app Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).						
Status						
1) Responsive to communication(s) filed on 29 Ja	nuary 2004.					
,						
3) Since this application is in condition for allowar	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims						
4)⊠ Claim(s) <u>11-19</u> is/are pending in the application.						
4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.						
6)⊠ Claim(s) <u>11-19</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers						
9) The specification is objected to by the Examiner.						
10)⊠ The drawing(s) filed on <u>29 January 2004</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).						
a) ☐ All b) ☐ Some * c) ☐ None of:						
•						
2. Certified copies of the priority documents have been received in Application No						
3. Copies of the certified copies of the priority documents have been received in this National Stage						
application from the International Bureau (PCT Rule 17.2(a)).						
* See the attached detailed Office action for a list of the certified copies not received.						
Attachment(s)		:				
1) Notice of References Cited (PTO-892) 4) Interview Summary (PTO-413)						
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail Do	ate Patent Application (PTO-152)				
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 3/3/06& 1/26/04.	6) Other:					

Application/Control Number: 10/767,618

Art Unit: 1725

DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 11, 12, and 15 are rejected under 35 U.S.C. 102(b) as being anticipated by Lai (US Patent No. 6,231,566).

Lai teaches a laser ablating system "100" comprising: a laser source "10", a beam shaping optics "20", a scanner "40" made up of galvanometer scan mirrors, and a computer or tool path control module "50". Said laser ablation system operable to determine a tool path for ablating a layer of material from an exposed surface of a workpiece (cornea) with laser (see, column 4, lines 17-41); wherein the tool path describes a substantially constant arc speed (see, column 2, lines 3-35); a plurality of lasers (see, column 4, lines 8-16) controlled by said tool path control module to perform ablation of a plurality of workpieces according to the tool path, and wherein said tool path module is operable to formulate a radius and a local angular speed (see, column 4, lines 8-41, figures 1 and 3-5).

Regarding claims 16. Lai laser ablating system is operable to ablate or remove successive layers of corneas; wherein each of the corneas is composed of substantially identical material and has substantially identical geometric characteristics and each of the multiple regions the corneas are composed of substantially identical

Application/Control Number: 10/767,618

Art Unit: 1725

material and has substantially identical geometric characteristics (see, column 1 lines 14-20, column 5, lines 7-33).

Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).
- 5. Claims 13 and 14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lai (US Patent No. 6,231,566) in view of Cutler et al. (US 5,798,927).

Lai teaches the elements of claims 11 and 12, as above and, further teaches varying the radius according to a tool pitch by the scanning speed, and wherein said tool path module is operable to determine a tool pitch based on a spot size of the plurality of lasers, but Lai does not expressly teach PZT scan mirror in his disclosed system.

Application/Control Number: 10/767,618

Art Unit: 1725

However, Cutler et al. teaches a laser milling system for performing tool path operation using a piezoelectric transducer as a scanning device which is operable controls the repetition rate and the spot size and positioning by variation of the applied voltage across it (see, Cutler et al., column 10, lines 27-41, and figure 2).

It would have been obvious to one of ordinary skill in the art at the time the applicants' invention was made to have modified the system of Lai by using a PZT scanner as taught by Cutler et al., wherein doing so would have meant, substituting one form of positioning device for another in the same art which would have enabled the appropriate setting of tool pitch for a preferred spot size base on applied voltage per revolution (see, Cutler et al., column 10, lines 27-41).

Conclusion

- 6. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Nodal et al. (US 5,948,289), Miyakawa et al. (US 6,091,047) and Sievers (US 6,150,629) are also cited in PTO-892.
- 7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michael Aboagye whose telephone number is 571-272-8165. The examiner can normally be reached on Mon Fri 8:30am 5pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Patrick Ryan can be reached on 571-272-1292. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Page 5

Application/Control Number: 10/767,618

Art Unit: 1725

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system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

LAML.

Michael Aboagye Assistant Examiner

Art Unit 1725

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